

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Kazunari SEKIGAWA, et al.

Serial No. 10/809,372

Group Art Unit: 1795

Confirmation No. 7624

Filed: March 26, 2004

Examiner: YOUNG, CHRISTOPHER G

For: EXPOSING APPARATUS AND EXPOSING METHOD, FOR MASKLESS EXPOSURE
OF SUBSTRATE TO BE EXPOSED, AND PLOTTER AND PLOTTING METHOD FOR
DIRECTLY PLOTTING ON OBJECT TO BE PLOTTED

RESPONSE TO ELECTION/RESTRICTION REQUIREMENT

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

This is in response to the Office Action mailed December 27, 2007, and having a period
for response set to expire on January 27, 2008.

The following amendments and remarks are respectfully submitted. Reconsideration of
the claims is respectfully requested.